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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

01/18/2007 16:34 FAX 408 982 8210

Blaine R. Spady; John D. Heaton; Robert Buchanan; Richard A. Yarussi

Assignee:

Nanometrics Incorporated

Title:

Metrology/Inspection Positioning System

Serial No.:

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Gordon Stock

Group Art Unit:

2877

Docket No.:

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Confirmation No.:

8470

Santa Clara, California January 18, 2007

Mail Stop RCE Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

<u>AMENDMENT</u>

Dear Sir:

This Amendment is filed with a Request for Continued Examination. Please enter the following amendments before taking action on the merits of the above-referenced application.

SILICON VALLEY PATENT GROUP ILE

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Serial No. 09/458,123